



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	Francis T. McQuade	Docket:	102276-200
	Charles L. Barto		
Serial No.:	10/027,146	Art Unit:	2829
Filed:	December 20, 2001	Examiner:	J. Hollington
Assignee:	Wentworth Laboratories, Inc.	Conf. No.	3054
Title:	METHOD FOR CHEMICALLY ETCHING PHOTO-DEFINED MICRO ELECTRICAL CONTACTS		

Certificate of Mailing

Date of Deposit February 20, 2004.

I hereby certify under 37 CFR 1.8(a) that this correspondence (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signed: William A. Simons

Name: William A. Simons

**SUPPLEMENTAL AMENDMENT
UNDER 37 CFR 1.121**

Mail Stop Non-Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In the matter of the above-identified application for Letters Patent and supplemental to the Amendment filed February 17, 2004, please enter and consider the following Amendment and Remarks:

Amendments to the Drawings begin on page 2 of this paper and include 7 attached replacement sheets.

Remarks begin on page 3 of this paper.

AMENDMENTS TO THE DRAWINGS

The attached sheet of drawings includes FIG(S) 1 to 13. These sheets, which includes FIG(S) 1 to 13, replaces the original sheets including FIG(S) 1-13.